


<b>Search Notes</b>  	<b>Application/Control No.</b>  10581589	<b>Applicant(s)/Patent Under Reexamination</b>  KOYAMA, RIKA
	<b>Examiner</b>  Chen-Wen Jiang	<b>Art Unit</b>  3744

SEARCHED			
Class	Subclass	Date	Examiner
62	157		
701	1,36		
367	198		
340	460,825.24,825.19		
704	275,243	6/24/10	CJ

SEARCH NOTES		
Search Notes	Date	Examiner
EAST Searched		
Inventor Searched	6/24/10	CJ

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

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